

Commissioner of Patents and Trademarks Washington, D.C. 20231

George O. Saile, Reg. No. 19,572 20 McIntosh Drive Poughkeepsie, N.Y. 12603 #18/E 2/26/63 Hayes

Subject:

Serial No.: 09/325,951

Filed: 06/04/99

Inventor: Min-Hsiung Chiang

Title: Method For Forming High Purity Silicon Oxide Field

Oxide Isolation Region

Group Art Unit: 2812

Examiner: Pompey, R. E.

Attorney Docket: TSMC 98 - 262CC

RESPONSE TO PATENT OFFICE ACTION

Dear Sir:

In response to the office action dated 11/05/02, please consider the

following remarks:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patent and Trademarks, Washington, D.C. 20231, on Santaguay 2002.

Signature/Date

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